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IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Teruhiko OISHI

Conf. 2292

Application No. 10/527,802

Group 1797

Filed September 22, 2005

Examiner A. Fortuna

PLASMA PURIFICATION MEMBRANE AND PLASMA
PURIFICATION SYSTEM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying documents, copies of which are attached to this statement, are made of record on the enclosed Form PTO-1449.

A concise explanation of the relevance of these items is that these references were cited by the European Patent Office in the corresponding European Application Serial No. EP 03 79 5429.

Under the provisions of 37 CFR 1.97(e), the undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a

counterpart foreign application not more than three months
prior to the filing of this Statement.

Respectfully submitted,

YOUNG & THOMPSON

Benoit Castel Reg. No. 35,041 for

Robert J. Patch, Reg. No. 17,355
209 Madison Street, Suite 500
Alexandria, VA 22314
Telephone (703) 521-2297
Telefax (703) 685-0573
(703) 979-4709

RJP/lk

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